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- ☐ Home
- ☐ What Can I Access?
- ☐ Log-out

Tables of Contents

- ☐ Journals & Magazines
- ☐ Conference Proceedings
- ☐ Standards

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- ☐ By Author
- ☐ Basic
- ☐ Advanced
- ☐ CrossRef

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1 A high-resolution silicon monolithic nozzle array for inkjet printing

Jingkuang Chen; Wise, K.D.;

Electron Devices, IEEE Transactions on, Volume: 44, Issue: 9, Sept. 1997

Pages:1401 - 1409

[\[Abstract\]](#)

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IEEE JNL

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[Home](#) | [Log-out](#) | [Journals](#) | [Conference Proceedings](#) | [Standards](#) | [Search by Author](#) | [Basic Search](#) | [Advanced Search](#) | [Join IEEE](#) | [Web Account](#) | [New to week](#) | [OPAC Linking Information](#) | [Your Feedback](#) | [Technical Support](#) | [Email Alerting](#) | [No Robots Please](#) | [Release Notes](#) | [IEEE Online Publications](#) | [Help](#) | [FAQ](#) | [Terms](#) | [Back to Top](#)